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DECEMBER 21, 2007
By: Sharon M. Fujita
Sharon M. Fujita

Attorney Docket No: 0123.210US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Sun Ai Raillard, *et al.*

Application No.: 09/502,283

Filed: February 11, 2000

For: HIGH THROUGHPUT MASS SPECTROMETRY

Examiner: Jon D. Epperson

Art Unit: 1639

**AMENDMENT UNDER 37 C.F.R. §
1.116**

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Commissioner for Patents
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Sir:

The following amendments and remarks address the rejections raised in the Final Office Action mailed December 12, 2007.

Applicants respectfully request consideration of the following amendments and remarks

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this submission.

Remarks begin on page 8 of this submission.